



**ELECTRONIC COPY**

LG642405952  
Report verification at igi.org



September 26, 2024

IGI Report Number **LG642405952**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **9.83 X 7.04 X 4.57 MM**

**GRADING RESULTS**

Carat Weight **3.05 CARATS**

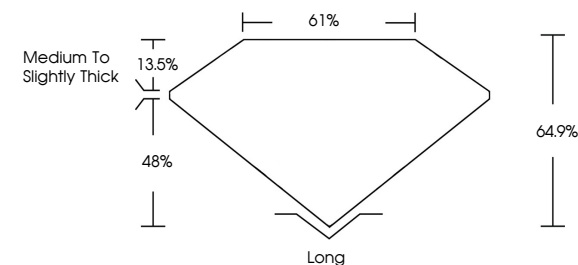
Color Grade **G**

Clarity Grade **VS 2**

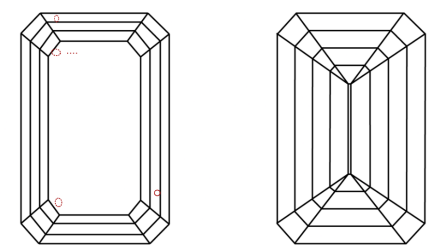


Sample Image Used

**PROPORTIONS**



**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

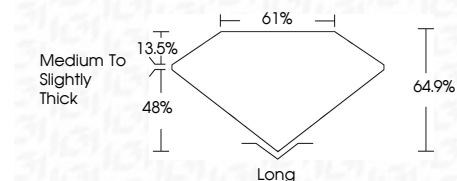
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D	E	F	G	H	I	J	Faint	Very Light	Light
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**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG642405952**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa



**IGI**



September 26, 2024  
IGI Report No. LG642405952  
**EMERALD CUT**

**3.05 CARATS**  
Color Grade **G**  
Clarity Grade **VS 2**  
Depth **64.9%**  
Table **61%**  
Girdle **Medium to Slightly Thick**

Culet **Long**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
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